

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

U. S. Patent No.: 6,989,546
Applicant: Hans Loschner et al.
Issued: January 24, 2006
Title: PARTICLE MULTIBEAM LITHOGRAPHY
Confirmation No.: 5361
Docket No.: IMSN-121US

**NOTIFICATION OF ERROR IN PAYMENT OF FEE(S) AS A SMALL ENTITY
(37 C.F.R. § 1.28(c))****Erroneous Filing of Small Entity Statement**

1. On August 22, 2005, the Assignee, IMS Nanofabrication GmbH, lost entitlement to small entity status.
2. On July 16, 2009 the maintenance fee was erroneously paid as a small entity in this
☐ application
☒ patent
2. This assertion of small entity status in this application and the payment of fees as a small entity was made in good faith.
3. It has now been discovered that loss of such status was not previously reported.

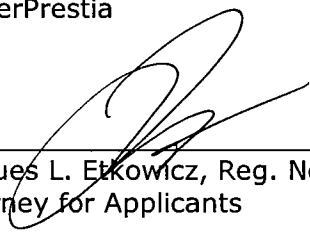
Itemization of the Fees Erroneously Paid as Small Entity

Type of Fee	Current Fee Amount	Small Entity Fee Paid	Date Small Entity Fee Paid	Deficiency Owed
4 year Maintenance Fee	\$980	\$490	July 16, 2009	\$490
Total Deficiency due				\$ 490

Authorization is given for payment by credit card of the deficiency fees (\$490) and the processing fee under 37 C.F.R. § 1.17(i) (\$130). Form PTO-2038 is attached.

Respectfully Submitted,

RatnerPrestia



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JLE/kpc

Attachment: Form PTO-2038

Dated: February 17, 2010

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The Director is hereby authorized to charge or credit Deposit Account No. **18-0350** for any additional fees, or any underpayment or credit for overpayment in connection herewith.